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SERIAL NUMBER 10/806,521	FILING DATE 03/23/2004 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 5649-1226
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APPLICANTS

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** CONTINUING DATA *****

None WLL

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2003-18275 03/24/2003 WLL

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <u>WLL</u> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 9	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 4
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TITLE
 Methods of fabricating a semiconductor substrate for reducing wafer warpage

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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